

Docket Number: 081468-0306001

Client Reference: P-0358.010-US



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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

KONSTANTIN NIKOLAEVITCH KOSHELEV,
et al.

Group Art Unit: 2881

Application No.: 10/664,065

Examiner: Anthony G. Quash

Filed: September 17, 2003

Confirmation No.: 3252

For: RADIATION SOURCE, LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING
METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Copies of the references are enclosed. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicant respectfully requests the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicant with the next Office communication to indicate that the references have been considered, per MPEP § 609.

I hereby certify that each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

The references were cited in a Japanese Official Action for a counterpart application. An English language translation of the Official Action, as well as English language Abstracts of the references cited therein are attached hereto.

Respectfully Submitted,

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Date: March 19, 2007
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Atty.
Dkt. No.

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Applicant: Konstantin KOSHELEV et al.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Date: March 19, 2007

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U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR					
	BR					
	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					
	NR					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
	OR 2003-503814	01/2003	Japan		X			
	PR 2001-160499	06/2001	Japan	OZU	X			
	QR 2000-298200	10/2000	Japan	KOJIMA et al.	X			
	RR 4-110800	04/1992	Japan	JINNO	X			
	SR 2003-051398	03/2003	Japan	KONDO	X			
	TR							
	UR							

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

VR	English Translation of Japanese Office Action in Japanese Patent Application No. 2003-363845, dated January 31, 2007			
WR				
XR				
YR				
ZR				
AAF				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.